

AP/2800

TSMC-00-166



May 13, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 09/679,514
| Hung-Jen Hsu

10/06/001
JUN 10 2003
TECHNOLOGY CENTER 2800

"A METHOD TO IMPROVE PASSIVATION
OPENINGS BY REFLOW OF PHOTORESIST
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated April 1, 2003,
please amend the above-identified application for patent as
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents
P.O. Box 1450, Alexandria, VA 22313-1450, on June 2,
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature
Date 6/2/03